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APPLICANTS

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** CONTINUING DATA *MK (Verified)*

** FOREIGN APPLICATIONS *MK (Verified)*
 JAPAN P2000-214974 07/14/2000
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35 USC 119 (a-d) conditions met
☒ yes ☐ no ☐ Met after Allowance

Verified and Acknowledged
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TITLE
 Substrate cleaning method and substrate cleaning apparatus

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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